

FORM PTO-1449 (modified)  
To: U.S. Department of Commerce  
(PM&S FORM PAT-1449)  
Patent and Trademark Office



Atty. Dkt. No.	M#	Client Ref.
	284105	P-0294.000-US

**INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT**

Applicant: VAN SCHAIK et al	
Application No.: 09/988,830	
Filing Date: November 19, 2001	
Examiner: Unknown	Group Art Unit: 1750-2851

Date: April 16, 2002 Page 1 of 1

**U.S. PATENT DOCUMENTS**

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
HN	AR	6,252,648	06/2001	HASE et al.	355	53	
	BR						
	CR						
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	FR						
	GR						
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	JR						
	KR						
	LR						
	MR						
	NR						

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**FOREIGN PATENT DOCUMENTS**

SECRETARY DOCUMENTS							Abstract		Readily Available	
		Document Number	Date MM/YYYY	Country	Inventor Name		Enclosed	No	Enclose	No
	OR									
	PR									
	QR									
	RR									
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	WR									
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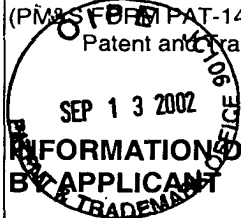
**OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

YR										
ZR										
AAR										
BBR										
CCR										
DDR										

Examiner Hung Henry Nguyen Date Considered: 1/9/03

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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	284105	P-0294.000-US
Applicant: VAN SCHAIK et al		
Application No.: 09/988,830		
Filing Date: November 19, 2001		
Examiner: Unknown		Group Art Unit: 2851

Date: September 13, 2002 Page 1 of 1

**U.S. PATENT DOCUMENTS**

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
HN	AR	6,411,368	06/2002	MATSUMOTO et al.	355	67	
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	FR						
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	IR						
	JR						

**FOREIGN PATENT DOCUMENTS**

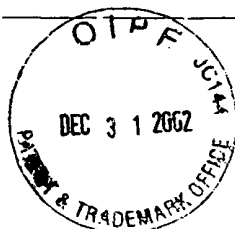
		Document Number	Date MM/YYYY	Country	Inventor Name		English Abstract		Translation Readily Available	
							Enclosed	No	Enclose	No
HN	KR	0 660 188 A1	06/1995	EUROPE	STRAAIJER et al.					
	LR									
	MR									
	NR									
	OR									
	PR									
	QR									

**OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

HN	RR	Bloomstein et al., "UV Cleaning of Contaminated 157-nm Reticles," <i>Proceedings of SPIE</i> 4346:669-375 (2001)			
	SR	Liberman, "Reticle Materials Testing Facilities at MIT Lincoln Laboratory," presented March 9, 2000			
	TR	Bloomstein et al., "UV Cleaning of Contaminated Reticles," presented August 1, 2000			
	UR	Bloomstein et al., "Studies of Laser Induced Contamination and Cleaning," presented November 21, 2000			
	VR	Bloomstein et al., "Optical Materials and Coatings at 157 nm," <i>Proceedings of SPIE</i> 3676:342-349 (1999)			
	WR	Bloomstein et al., "Laser Cleaning of Optical Elements in 157-nm Lithography," <i>Proceedings of SPIE</i> 4000:1537-1545 (2000)			
HN	XR	Bloomstein et al., "Controlled Contamination of Optics Under 157-nm Laser Irradiation," <i>Proceedings of SPIE</i> 4346:685-694 (2001)			

Examiner Hung Henry Nguyen Date Considered: 11/9/03

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**INFORMATION DISCLOSURE STATEMENT  
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Applicant: VAN SCHAIK et al

Application No.: 09/988,830

Filing Date: November 19, 2001

Date: December 31, 2002 Page 1 of 1

Examiner: Unknown Group Art Unit: 2851

**U.S. PATENT DOCUMENTS**

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
HN	AR 6,387,602	05/2002	HAYDEN et al.	438	327	
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	CR					
	DR					
	ER					
	FR					
	GR					
	HR					
	IR					
	JR					

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FOREIGN PATENT DOCUMENTS							English Abstract		Translation Readily Available	
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